



image

2814

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the application of
HORNING et al.

Serial Number:
09/873,931

Filed: June 4, 2001

For:
APPLICATIONS OF A
STRAIN-COMPENSATED
HEAVILY DOPED ETCH STOP
FOR SILICON STRUCTURE
FORMATION

Group Art Unit:
2814

Examiner:
Steven H. Rao

Docket No. H16-16009

To the Commissioner of Patents and Trademarks:

Sir:

IDS TRANSMITTAL

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Sir:

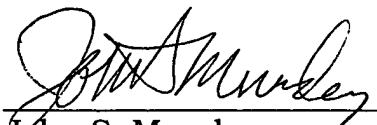
Enclosed please find an Information Disclosure Statement by Applicant and copies of the four (4) references cited therein. Also enclosed is a copy of the PCT International Search Report dated August 11, 2003. No fee is due because this submission is within two months of the date of the Search Report.

DATE: 18 September 2003

Respectfully submitted,
Robert Horning et al.

By their Attorney

Telephone:
(763) 444-8296
FAX
(763) 444-8781


John S. Munday
Law Offices of John S. Munday
PO BOX 423
Isanti, MN 55040

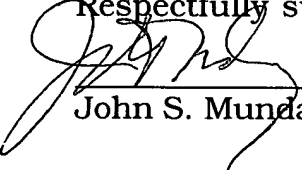


CERTIFICATE OF MAILING

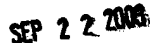
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DATE: 18 September 2003

Respectfully submitted,



John S. Munday



Approved for use through 07/31/2006. OMB 0651-0031

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INFORMATION DISCLOSURE STATEMENT BY APPLICANT

(Use as many sheets as necessary)

Sheet	one	of	one
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Complete if Known

Application Number	09/873,931
Filing Date	June 4, 2001
First Named Inventor	Robert Horning
Art Unit	2814
Examiner Name	Steven H. Rao
Attorney Docket Number	H16009US

U. S. PATENT DOCUMENTS

FOREIGN PATENT DOCUMENTS

**Examiner
Signature**

Date
Considered

*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant. ¹Applicant's unique citation designation number (optional). ²See Kinda Codes of USPTO Patent Documents at www.uspto.gov or MPEP 901.04. ³Enter Office that issued the document, by the two-letter code (WIPO Standard ST.3). ⁴For Japanese patent documents, the indication of the year of the reign of the Emperor must precede the serial number of the patent document. ⁵Kind of document by the appropriate symbols as indicated on the document under WIPO Standard ST.16 if possible. ⁶Applicant is to place a check mark here if English language Translation is attached.

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